

## THE UNITED STATES PATENTS AND TRADEMARK OFFICE

K-1984

Applicant

: Yasumi Sago et al.

Title

: ELECRO-STATIC CHUCKING MECHANISM AND

SURFACE PROCESSING APPARATUS

Serial No.

: 09/879,934

Filed

: June 14, 2001

Group Art Unit: 1763

Examiner

: Ram N. Kackar

Hon. Commissioner of Patents

P.O. Box 1450, Alexandria, VA 22313-1450

February 19, 2004

## AMENDMENT

## Sir:

In response to the communication of February 17, 2004, please amend the application, as follows:

Amendments to the Claims

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Remarks